

Under certain conditions, defects are related to the O₂ partial pressure.

↳ Brønstedt diagrams: [Defect] vs. P_{O₂} at a given T.

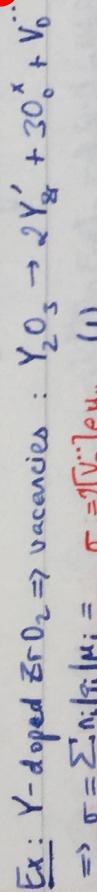
IV. Effect of defects on material properties

a) Defects & conductivity

Defect motion in solids (e.g. by vacancy or interstitial diffusion) \Rightarrow mass & charge transport.

• Electrical conductivity: charge motion under an applied electric field. I: ionic, electronic & mixed conductivity.

Ionic conductors: In ionic crystals, defects have charge $\sigma_{(V_0^{\prime\prime})} \neq \sigma_{(V_0^{\prime})}$, this is a class of materials called ionic conductors.



$$\Rightarrow \sigma = \sum_i n_i q_i / \mu_i = \sigma = 2[V_0^{\prime\prime}] e \mu_V. \quad (1)$$

But vacancy diffusion is thermally activated due to temp.-dependent diffusivity D:

$$D = D_0 \exp \left(- \frac{\Delta G_m}{RT} \right) \quad (2)$$

From eq. (1): $[V_0^{\prime\prime}] \propto \sigma \Rightarrow \sigma \propto \sigma$, BUT in, e.g. Ca₂, max(σ) occurs for low dopant content.

When the vacancy content increases, I defect association: $Y_2' + V_0'' \rightarrow \{Y_2', V_0''\}$

↳ Defects aren't "free" to be involved in transport processes: at high [X], enough defects for them to interact through Coulomb attraction & form defect pairs & clusters.

$$\text{Defect reaction: } Y_2' + V_0'' \Rightarrow \{Y_2', V_0''\} \Rightarrow K_{ass} = \frac{[Y_2'][V_0'']}{[Y_2'][V_0'']} = \exp \left(- \frac{\Delta G_a}{kT} \right)$$

Electronic conductors: • Metallic conductors: the valence band isn't filled $\Rightarrow e^-$ are easily promoted to LUMO $\rightarrow \sigma \sim [10^2; 10^8] \text{ S cm}^{-1}$

• Semiconductors: I an energy gap between HOMO & LUMO, if $E \in [0, 5; 3] \text{ eV}$

• Insulators: Eg > 3 eV

The degree of overlapping of bands defines conduction mechanism. For metals $\sigma \propto e^{-T^\alpha}$, for insulators of SC: $T^\alpha \rightarrow \sigma \propto T^\beta$,